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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Ren et al.

Examiner: McNeil, Jennifer C.

Serial No.: 10/660,348

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Group Art Unit: 1775

Entitled: Metal Oxide Nanostructures with Hierarchical Morphology

Conf. No.: 5141

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8a**

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**AMENDMENT**

Sir:

This Amendment is being filed in response to the Office Action mailed from the U.S. Patent and Trademark Office on April 1, 2005 in the above-identified application. Reconsideration and further examination are requested.

**Amendments to the Claims** are shown in the "Listing of the Claims" which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

Please enter the following amendments and remarks.